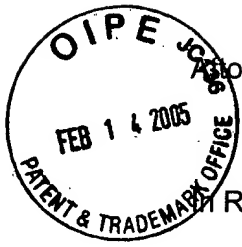


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Attorney's Docket No.: 042390P4220

Patent

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Re Application of:

Mark T. Bohr

Examiner: Guerrero, Maria F.

U.S. Serial No: 09/002,178

Art Unit: 2822

Filed: December 31, 1997

For: WAFER PASSIVATION STRUCTURE  
AND METHOD OF FABRICATION

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**FORMAL DRAWINGS SUBMISSION**

Enclosed herewith for submission in the United States Patent and Trademark Office  
are nine (9) sheets of formal drawings for the patent application referenced above.

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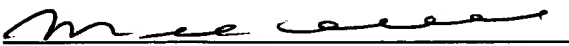
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Respectfully submitted,

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Dated: 2/11, 2005



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